IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Nassiopoulou et al. Applicant: Serial No.: 10/502,465 Confirmation: 3973 Filed: July 23, 2004 Title: Low Power Silicon Thermal Sensors and Microfluidic Devices Based on the Use of Porous Sealed Air Cavity Technology or Microchannel Technology Group Art Unit: 2884 Examiner: Rosenberger, Frederick F. Attorney Docket No.: 30848/40323

AMENDMENT "B"

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

In response to the final official action dated February 9, 2006, please amend the above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Amendments to the specification begin on page 6 of this paper.

Remarks begin on page 7 of this paper.